IN THE WRITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Mamoru NAKASUJI et al.

Group Art Unit: 2881

Serial No.: 09/891,611

Examiner: Jack I. Berman

Filed: June 27, 2001

Confirmation No.: 8874

For:

INSPECTION SYSTEM BY CHARGED PARTICLE BEAM AND METHOD OF MANUFACTURING DEVICES USING THE

**SYSTEM** 

Attorney Docket Number: (

010817

Customer Number:

38834

## PETITION FOR EXTENSION OF TIME

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Date: January 26, 2005

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated September 29, 2004 for one month from December 29, 2004 to January 29, 2005.

Attached please find a check in the amount of \$120.00 to cover the cost of the extension.

If any additional fees are due in connection with this paper, please charge our Deposit Account.

No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANJELS & ADRIAN, LLP

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